



INDIAN INSTITUTE OF TECHNOLOGY BOMBAY

MATERIALS MANAGEMENT DIVISION

12th July, 2021

Corrigendum –I

For (PR No. 100020717) RfX No. 6100000743

Plasma Etcher with Deposition Capability

Sr. No.	Online RfX Clause	Previous Clause	Changed Clause
1.	Technical Specification change	Control Module 1) System control 1.7) UPRO Process control software	Control Module 1) System control 1.7) Process Control software

Additional Registrar

Materials Management Division